Yale University
School of Engineering & Applied Science

MEMS Committee Action Form

FALL TERM
SPRING TERM
1 Year of Study

NAME _____ _____ **Date** _____
last *first*

_____ _____
address *office/home phone*

COMMITTEE MEMBERSHIP CHANGE
Have newly constituted committee sign

Signatures of Committee Members indicate confirmation of membership.

AREA EXAM
DISSERTATION DEFENSE

Pass

Fail

THESIS PROSPECTUS (attach)

Accept

Revision Required

Reject

THESIS PROGRESS
(Meeting for the DPR)

Approve

Disapprove

Committee must provide detailed comments for any decision of Fail, Revision Required, Reject or Disapprove.

Comments:

	Name	Dept	Signature
Committee Members:			
	(Chair/Advisor)		

Please email signed form as a PDF to annette.myers@yale.edu